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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Muneki HAMASHIMA et al.**

Group Art Unit: **2821**

Application Number: **10/697,647**

Examiner: **Thuy V. Tran**

Filed: **October 31, 2003**

Confirmation Number: **8467**

For: **ELECTRON BEAM APPARATUS AND DEVICE  
MANUFACTURING METHOD USING THE SAME**

Attorney Docket Number: **032082**

Customer Number: **38834**

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

June 8, 2006

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated March 6, 2006 for one month from June 6, 2006 to July 6, 2006.

Attached please find a check in the amount of \$120.00 for the cost of the extension. If any additional fees are due in connection with this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

**WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP**

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